

PATENT

Atty. Dkt. No. AMAT/2601.P11/CMP/ECPI/RIKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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CENTRAL FAX CENTERIn re Application of:
Mok, et al.

Group Art Unit: 1763

MAR 08 2004

Serial No.: 09/785,815

Examiner: Sylvia MacArthur

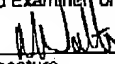
OFFICIAL

Confirmation No.: 4127

Filed: February 16, 2001

For: INTEGRATED SEMICONDUCTOR
SUBSTRATE BEVEL CLEANING
APPARATUS AND METHODCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8	
I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703-872-9306 to the attention of the named Examiner on the date below.	
3/8/04 Date	 Signature

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RESPONSE TO FINAL OFFICE ACTION DATED JANUARY 7, 2004

In response to the Final Office Action dated January 7, 2004, having a shortened statutory period for response set to expire on April 7, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/2601.P11/NAN, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Applicants Remarks begin on page 6 of this paper.